



**ELECTRONIC COPY**

LG760506804  
Report verification at igi.org



January 7, 2026  
IGI Report Number **LG760506804**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **10.16 X 7.12 X 4.40 MM**

**GRADING RESULTS**

Carat Weight **3.23 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

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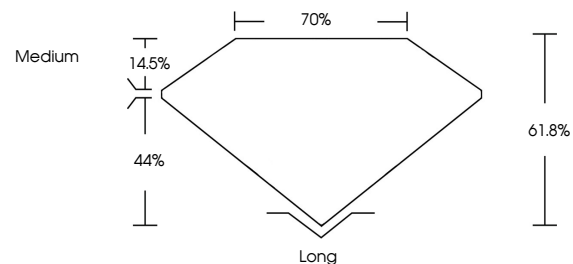
Carat Weight **3.23 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG760506804**

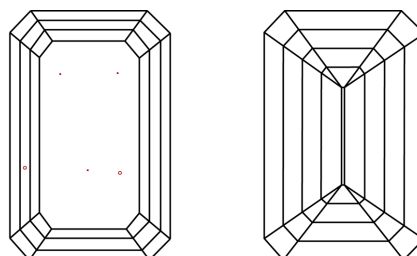
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

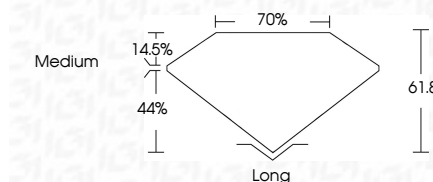
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No LG760506804  
EMERALD CUT

3.23 CARATS  
E

10.16 X 7.12 X 4.40 MM

Carat Weight  
Color Grade  
Clarity Grade  
Depth  
Table  
Girdle

3.23 CARATS  
E  
VS 1  
61.8%  
70%  
Medium

Long  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG760506804

Culet  
Polish  
Symmetry  
Fluorescence  
Inscription(s)

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